

5117
AUG 20 2002
LIST OF PATENTS AND
PUBLICATIONS
FOR APPLICANTS INFORMATION
DISCLOSURE STATEMENT

FORM PTO-1449 (MODIFIED)

ATTORNEY DOCKET NO.

SERIAL NO.

SP00-386

10/023,291

APPLICANT Berkey et al.

FILING DATE December 14,
2001

GROUP: 2874

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

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FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

J/H	AR	Kumar et al, "Effects of Deuterium Treatments on the Optical Properties of Fused Silica", <i>Laser Induced Damage in Optical Materials: 1981</i> , pp. 268-272
	AS	
	AT	
	AU	
	AV	
	AW	

EXAMINER:

DATE CONSIDERED:

4-09

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PATENT & TRADEMARK OFFICE

REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS					
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
	BN	09/558,770 ✓		Allen et al	—	—	04/26/00
	BO	09/722,804 ✓		Bookbinder et al	—	—	11/27/00
	BP	09/822,168 ✓		Berkey et al	—	—	03/31/01
	BQ	09/996,632 ✓		Berkey et al	—	—	11/28/01
	BR	10/023,291 ✓		Berkey et al	—	—	12/14/01
	BS	60/309,160 ✓		Berkey et al	—	—	07/31/02

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation Yes	No
	BT	10-68834 ✓	03/10/98	Japan	G02B	6/16		X
	BU	55-23081 ✓	02/19/80	Japan	C03B	37/00		X
	BV	57-17433 ✓	01/29/82	Japan	C03B	37/00		X
	BW	57-34034 ✓	02/24/82	Japan	C03B	37/00		X
	BX	60-71536 ✓	04/23/85	Japan	C03B	37/018		X
	BY	60-86043 ✓	05/15/85	Japan	C03B	37/018		X
	BZ	63-225546 ✓	09/20/88	Japan	C03B	37/018	X	
	CA	WO00/64824 ✓	11/02/00	PCT	C03B	37/00		
	CB	WO00/64825 ✓	11/02/00	PCT	C03B	37/014		

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

- CC Dianov et al, "Low-Hydrogen Silicon Oxynitride Optical Fibers Prepared by SPCVD", Journal of Lightwave Technology, July 1995, vol. 13, No. 7, pp. 1471-1474
- CD Diaz de la Iglesia et al, "Loss Spread in Single-Mode Fibers Due to OH-Ion Concentration and Transmitter-Wavelength Fluctuations", International Wire & Cable Symposium Proceedings 1987, pp. 629-639
- CE Hanawa et al, "Fabrication of Completely OH-Free V.A.D. Fibre", Electronics Letters, August 28, 1980, vol. 16, No. 18, pp. 699-700

EXAMINER:

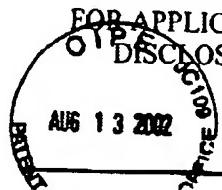
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AL	EP 0 785 448	07/23/97	Europe	G02B	6/16	
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